Since!



Examiner

Alonzo Chambliss

OTHER THAN A

Art Unit :

2827

Docket No.: 52433/609

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants

K. TATSUMI et al.

Serial No.

09/632,910

Filed

August 4, 2000

For

METHOD FOR FABRICATING A SEMICONDUCTOR DEVICE PROVIDED WITH

LOW MELTING POINT METAL BUMPS

Commissioner for Patents

P.O. Box. 1450

Alexandria, VA 22313-1450

TRANSMITTAL LETTER

SIR:

Transmitted herewith is an Amendment/Response in the above-identified patent application.

[X]

No additional fee is required.

The fee has been calculated as shown below.

SMALL ENTITY SMALL ENTITY ADDIT. OR CLAIMS HIGHEST NO. RATE RATE ADDIT. REMAINING PREVIOUSLY PRESENT FEE FEE AFTER PAID FOR EXTRA AMENDMENT TOTAL 8 MINUS 0.00 20 x18 =INDEP. 2 MINUS O 4 = x40 =Ś x86 =0.00 [] FIRST PRESENTATION OF MULTIPLE x135= x290 =0.00 DEP. CLAIM TOTAL ADDIT. FEE _ OR 0.00

[X] The Commissioner is hereby authorized to charge fees under 37 CFR 1.16 and 1.17 which may be required to Deposit Account 11-0600. A duplicate of this paper is enclosed.

A petition for a three (3) month extension of time and Deposit Account authorization to cover the extension fee are enclosed.

[] Priority Document.

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on November 20, 2003

TO TIVE

John J Kelly, Jr Reg No. 29 192

Respectfully submitted, KENYON & KENYON

John J. Kelly, Jr

Reg. No. 29,182

[X]



I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on November 20, 2003.

John J. Kelly, Jr. Reg. No.: 29,182

Examiner : Alonzo Chambliss

Art Unit : 2827

Docket No.: 52433/609

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: K. TATSUMI et al.

Serial No.: 09/632,910

Filed: August 4, 2000

For : METHOD FOR FABRICATING A SEMICONDUCTOR DEVICE

PROVIDED WITH LOW MELTING POINT METAL BUMPS

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT

SIR:

Reconsideration of the above-identified patent application, as amended, is respectfully requested. The present amendment is responsive to the Office Action mailed May 21, 2003. A petition for an extension of time in which to respond to the Office Action accompanies this amendment.